



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 4, 2025

IGI Report Number **LG720507905**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **7.78 X 5.48 X 3.73 MM**

GRADING RESULTS

Carat Weight **1.59 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

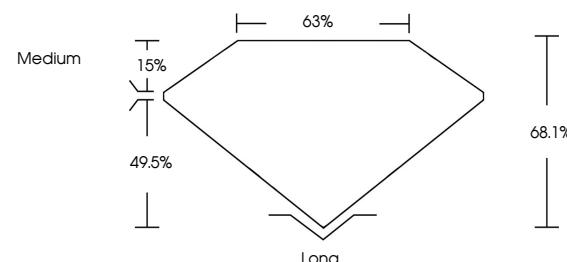
Symmetry **EXCELLENT**

Fluorescence **NONE**

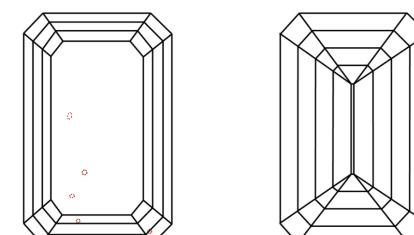
Inscription(s) **IGI LG720507905**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG720507905
Report verification at igi.org

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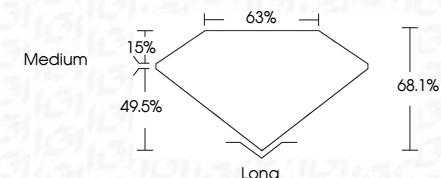
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Sample Image Used



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July 4, 2025	IGI Report No LG720507905	EMERALD CUT	1.59 CARAT	E	VS 1	68.1%	63%	Medium	Long	EXCELLENT	EXCELLENT	NONE	IGI LG720507905
			Carat Weight		Color Grade		Clarity Grade		Depth		Polish		Symmetry
									Table				Fluorescence
									Grade				Inscription(s)
													Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa